

Docket No.: 060188-0766



PATENT

AF/JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Response Under 37 CFR 1.116 - Expedited Procedure
: Customer Number: 20277
:
Taiji NODA : Confirmation Number: 2607
:
Application No.: 10/775,122 : Group Art Unit: 2812
:
Filed: February 11, 2004 : Examiner: LEE, Cheung
:

For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above-identified application.

- ☒ No additional fee is required.
☐ Applicant is entitled to small entity status under 37 CFR 1.27
☐ Also attached:

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	17	20	0	\$50.00 =	\$0.00
Independent Claims	2	3	0	\$200.00 =	\$0.00
Multiple dependent claims newly presented					\$0.00
Fee for extension of time					\$0.00
					\$0.00
Total of Above Calculations					\$0.00

- ☐ Please charge my Deposit Account No. 500417 in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.
- ☒ The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

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Date: April 20, 2006

Please recognize our Customer No. 20277 as our
correspondence address.



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Taiji NODA

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE

Application No.: 10/775,122

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Customer No.: 20277
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Examiner: LEE, Cheung

Title: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

RESPONSE UNDER 37 C.F.R. § 1.116

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Sir:

In response to the final Office Action dated January 23, 2006, having a three-month shortened statutory period for reply set to expire on April 23, 2006, Applicants respectfully request reconsideration of the pending rejections in view of the following remarks.